

U.S. Department of Commerce, Patent and Trademark Office

Document No.

Serial No.

AMAT/2905.P1

09/505,580

LIST OF RELEVANT ART CITED BY APPLICANT

(Use several sheets if necessary)

Applicant

Reimer et al.

Filing Date

02/16/1000

Group

Unknown

U.S. Patent Documents

*Examiner Initial		Document Number	Issue Date	Name	Class	Subclass	Filing Date If Appropriate
PRB	AA	5,944,049	08/31/1999	BEYER ET AL.	137	487.5	July 15, 1997
	AB						
	AC						
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	AJ						
	AK						

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Foreign Patent Documents

Translation

		Document Number	Date	Country	Class	Subclass	Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

	AQ	
	AR	
	AS	

Examiner

R. Buh

Date Considered

7-2002

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.

U.S. Department of Commerce Patent and Trademark Office (PTO Form 1449 modified)		Docket No. AMAT/2981.P1/ ECORE/CORE/MBE	Serial No. 09/505,580
LIST OF PATENTS AND PUBLICATIONS CITED BY APPLICANT		Applicant Reimer, et al.	Confirmation No. 5947
(Use several sheets if necessary)		Filing Date February 16, 2000	Group 2825
Examiner Unknown			

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RRB	A1	6,080,679	06-27-2000	Suzuki	438	726	05-19-1998
	A2	5,904,952	05-18-1999	Lopata, et al.	427	8	08-01-1997
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	B2	JP 4-358531 w/ English Abstract	12-11-1992	Japan	B01J	3/02		X
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RRB	C1	O'Hanlon, John F., "A User's Guide to Vacuum Technology," John Wiley & Sons, Inc., 2 nd Edition, 1989, Pages 349 - 352, 354.
RRB	C2	Beyer, et al., United States Patent Application, "An Apparatus and Method for Regulating a Pressure in a Chamber."

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LIST OF PATENTS AND PUBLICATIONS CITED BY APPLICANT (Use several sheets if necessary)		Applicant Reimer, et al.	Confirmation No. 5947
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							YES	NO
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	C1	
	C2	
	C3	

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